3700

503.30414V20

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

KATO, et al.

RECEIVED

Serial No.:

09/765,379

JUL 1 1 2001

Filed:

January 22, 2001

TECHNOLOGY CENTER R3700

VACUUM PROCESSING APPARATUS AND OPERATING

METHOD THEREFOR

SUPPLEMENTING INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97 & §1.98

Assistant Commissioner of Patents Washington, D.C.

July 6, 200

Sir:

The undersigned notes the Information Disclosure Statement submitted May 29, 2001, in connection with the above-identified application. An English-language abstract was submitted together with Japanese Patent Document No. 63-133521 enclosed with this Information Disclosure Statement.

To further facilitate consideration by the Examiner of Japanese Patent Document No. 63-133521, enclosed please find an English translation of this Japanese Patent Document No. 63-133521.

Particularly in view of the present submission of this English translation, and noting that there has not yet been a first Office Action on the merits in the above-identified application, full consideration of Japanese Patent Document No. 63-133521, upon examination of the above-identified application, is respectfully requested.

Please charge any shortage in fees due in connection with the filing of this paper to the Deposit Account No. 01-2135

(Case No. 503.30414V20) and please credit any excess fees to such Deposit Account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT, & KRAUS, LLP

William I. Solomon

Registration No. 28,565

1300 North Seventeenth Street

Suite 1800

Arlington, VA 22209

Tel.: 703-312-6600

Fax.: 703-312-6666

WIS/slk